

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Dewa

Attorney Docket: TI-31790

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For: Micromirror Truss Structure and Fabrication Method

INFORMATION DISCLOSURE STATEMENT

TRANSMITTAL

U.S. Patent and Trademark Office
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MAILING CERTIFICATE PURSUANT
TO 37 C.F.R. §1.10

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Joan K. Konkol
Joan K. Konkol

12-20-01
Date

Dear Sir:

Applicant wishes to bring to the attention of the Patent and Trademark Office the information noted on the enclosed PTO-1449 which may be considered material to the examination of the above identified application. This Information Disclosure Statement is submitted pursuant to 37 CFR 1.97(b) concurrently with the filing of the patent application. Consideration of the references is respectfully requested.

Respectfully submitted,

Kay Houston

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